

Docket No.: 0834-0243-0

**IN THE UNITED STATES PATENT & TRADEMARK OFFICE**

#8  
2-1-02  
Don

IN RE APPLICATION OF:

:

Hideaki SAKURAI, et al.

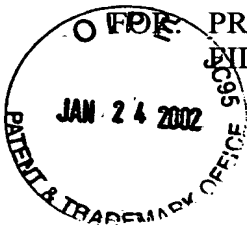
: EXAMINER: M. JACKSON

SERIAL NO: 09/457,743

:

FILED: DECEMBER 10, 1999

: GROUP ART UNIT: 1773



PROTECTIVE THIN FILM FOR FPDs, METHOD FOR PRODUCING SAID THIN FILM AND FPDs USING SAID THIN FILM

**RESPONSE TO RESTRICTION REQUIREMENT**

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

In response to the Office Action mailed September 24, 2001, the period for response having been extended to January 24, 2002, by a Petition for Extension of Time filed herewith, Applicants elect, with traverse, Groups I and II, Claims 1, (3-6)/1, and 18/1 and Claims 2, (3-6)/2, and 18/2 for further prosecution.

**REMARKS**

The Office has restricted this application as follows under 35 U.S.C. §121:

- |           |   |
|-----------|---|
| Group I:  | Claims 1, (3-6)/1, and 18/1, drawn to a protecting film comprising a substrate, an oxide film body, and a fluoride layer;               |
| Group II: | Claims 2, (3-6)/2, and 18/2, drawn to a protecting film comprising a substrate, an oxide film body, and a fluoride-coated powder layer; |

RECEIVED  
JAN 29 2002  
TC 1700